

## WAFER ALIGNER SERIES 150MM

**NOTCH OR FLAT ALIGNMENT, AUTOMATED OR MANUAL**

100/125MM WAFER HANDLING  
150MM WAFER HANDLING  
200MM WAFER HANDLING  
VACUUM HANDLING SYSTEMS  
RETICLE HANDLING

WAFER CARRIERS  
CARRIER HANDLES

**AFA  
150**

**MFA  
150**

**ANA  
150**

**MNA  
150**



### DESCRIPTION

EMU Technologies series of Wafer Alignment products are clean-concept, affordable batch alignment tools designed for either notch or flat wafers.

True ESD Protection and use of specific materials for all wafer & carrier contact points ensure clean and safe alignment.

The Automated Aligners start alignment upon placement of the carrier. The desired post alignment angle can be selected on the user-friendly keypad.

The Manual Aligners are highly cost-effective and have been designed for simple and straight-forward use, without compromising wafer safety & particle contamination.

### FACILITY REQUIREMENTS

100/240V AC – 50/60 Hz – 1.2 A

### SPECIFICATIONS (MM)

<b>AFA150:</b>	L 285 x W 220 x H 192mm
<b>MFA150:</b>	L 226 x W 175 x H 128mm
<b>ANA150:</b>	L 285 x W 220 x H 192mm
<b>MNA150:</b>	L 226 x W 175 x H 128mm



### RECIF TECHNOLOGY

This tool has been designed under license from Recif Technologies using the same design principles, materials and kinematics as were used in the original equipment and wafer fabs around the world.

SUPPLIERS TO THE SEMICONDUCTOR INDUSTRY

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